



Patent

Customer No. 31561
Docket No. 9407-US-PA
Application No.: 10/064,424

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Applicant : Ho et al.
Application No. : 10/064,424
Filed : 2002/7/12
For : HIGH DENSITY LAMINATED SUBSTRATE
STRUCTURE AND MANUFACTURE METHOD
THEREOF
Examiner : VIGUSHIN JOHN B
Art Unit : 2841

INFORMATION DISCLOSURE STATEMENT

ASSISTANT COMMISSIONER FOR PATENTS
Arlington, VA22202

Enclosed is a PTO Form 1449 listing 5 reference(s), including 3 Chinese patent applications, 1 Japanese patent application and 1 US patent application. Copies of the Chinese and Japanese patent applications are attached. Applicant submits the reference(s) in compliance with his duty of disclosure pursuant to 37 CFR § 1.56 and 1.97. The Examiner is requested to make the citation(s) of official record.

The IDS is being submitted after the mailing date of first office action dated September 2, 2004. Please charge the payment in the amount of US\$180.00 to account No. 50-2620 (Order No.: 9407-US-PA) to cover the fee set forth in 37 CFR 1.17(p).

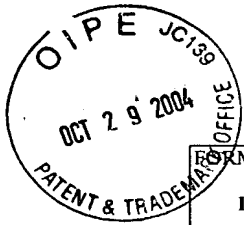
The submission of the reference(s) should not be interpreted as admitting them as prior art.

Respectfully Submitted,
JIANQ CHYUN Intellectual Property Office

Date: Oct. 27, 2004

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FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICATION	ATTY. DOCKET NO.: 9407-US-PA	APPLICATION NO.: 10/064,424
	APPLICANT: Ho et al.	
	FILING DATE: 2002/7/12	GROUP 2841

U.S. PATENT DOUUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FIILNG DATE (IF APPROPRIATE)
	6306511 B1	2001/10/23	Nakao et al.	428	426	2000/7/21

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	FIILNG DATE (IF APPROPRIATE)
	CN 1290033A	2001/04/04	CHINA.			2000/08/25
	CN 1053785C	2000/06/21	CHINA			1994/04/15
	CN 1286591 A	2001/03/07	CHINA			2000/08/25
	JP 09-051173	1997/02/18	JAPAN			1995/08/07

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

EXAMINER	DATE CONSIDERED
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EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEST COMMUNICATION TO APPLICANT.